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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

AP20 Rec'd OCT 20 20 APR 2006

In re application of :
Seiji AKITA et al. : **Mail Stop: PCT**
Serial No. NEW : Attorney Docket No. 2006_0598A
Filed April 20, 2006 :

NANOSIZE HEATER-MOUNTED
NOZZLE AND METHOD FOR
MANUFACTURING SAME AND
METHOD FOR FORMING MICRO
THIN FILM

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

[Corresponding to PCT/JP2004/015598
Filed October 21, 2004]

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced U.S. patent application please
amend the application as follows: